

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

DONG-WOO SHIN et al.

Application No.: 10/749,775

Filed: December 30, 2003

For: METHOD FOR FABRICATING
CAPACITOR OF SEMICONDUCTOR
DEVICE

Customer No.: 20350

Confirmation No. 1063

Examiner: Jack S.J. Chen

Technology Center/Art Unit: 2813

AMENDMENT AFTER ALLOWANCE
UNDER 37 CFR § 1.312

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date Uploaded: October 9, 2007

Sir:

In response to the Notice of Allowance mailed August 23, 2007, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.